

1/17

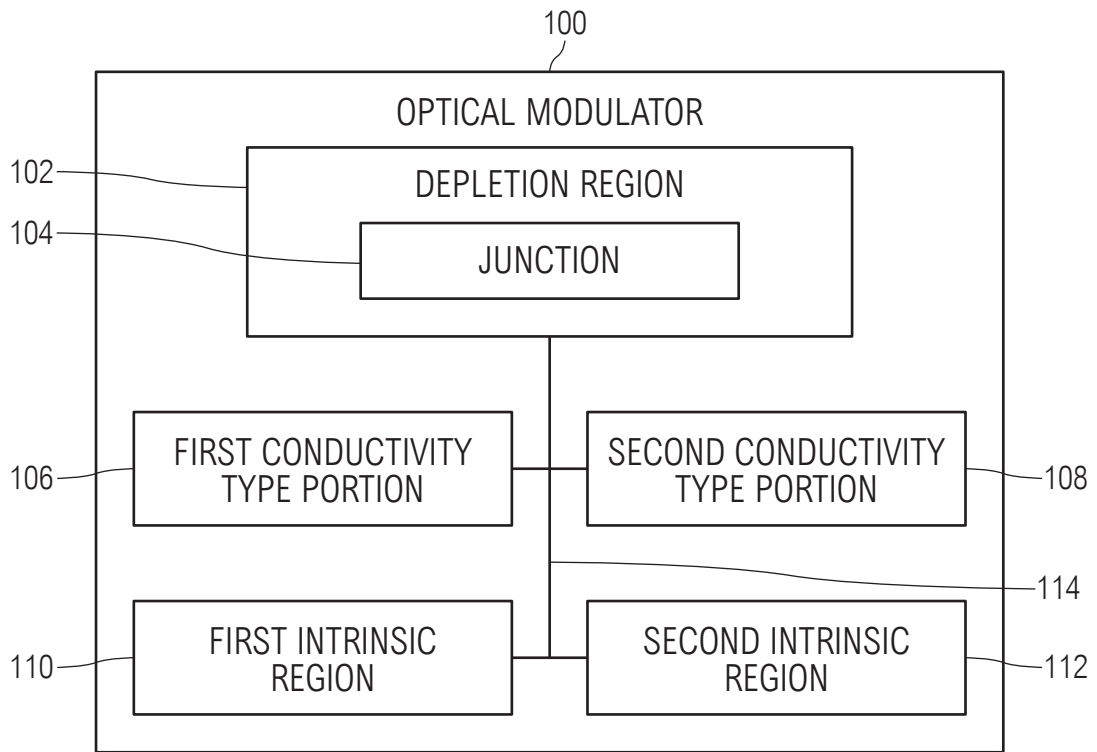


FIG. 1A

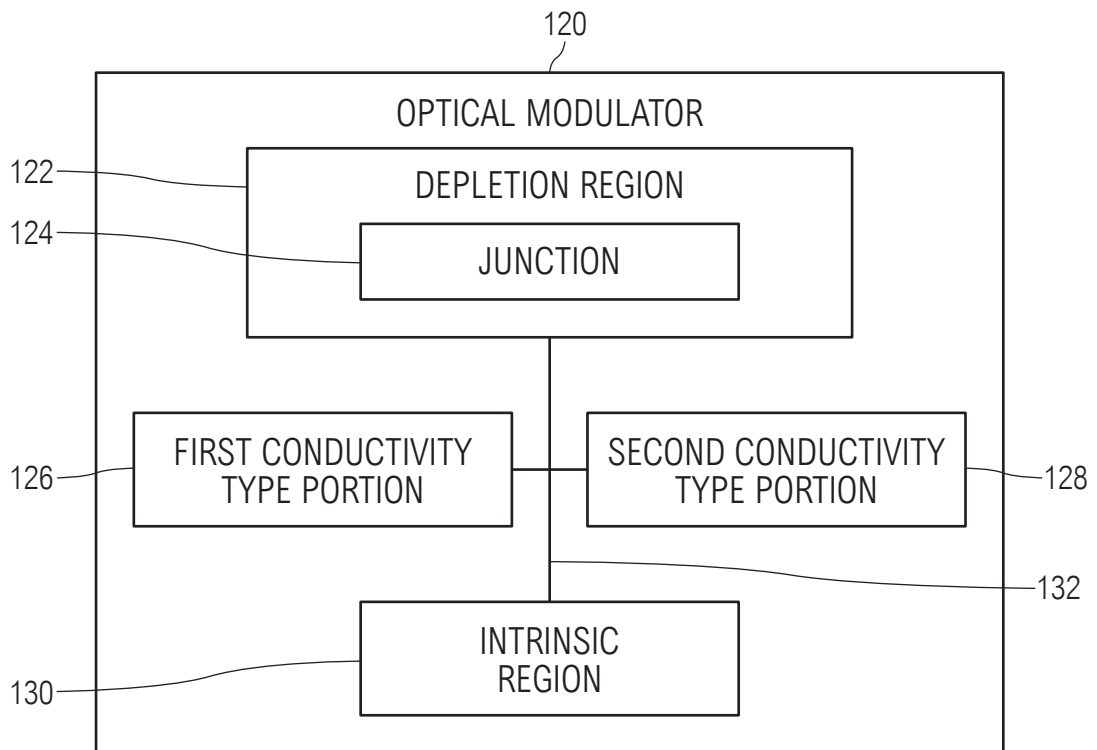


FIG. 1B

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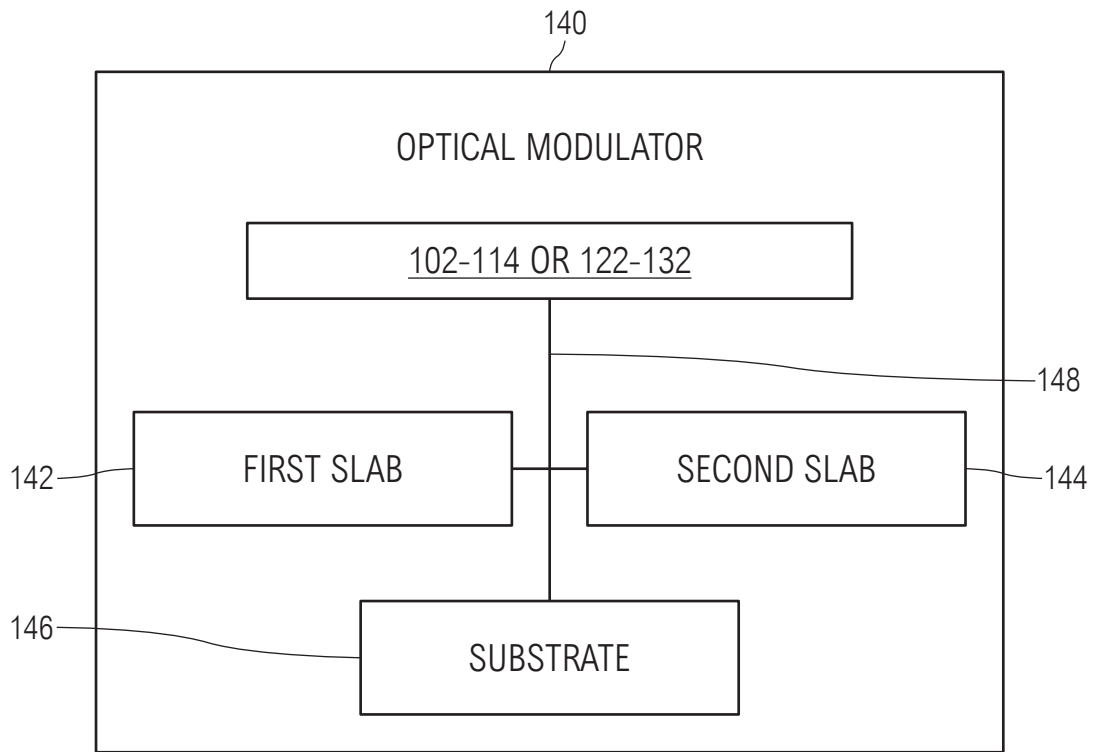
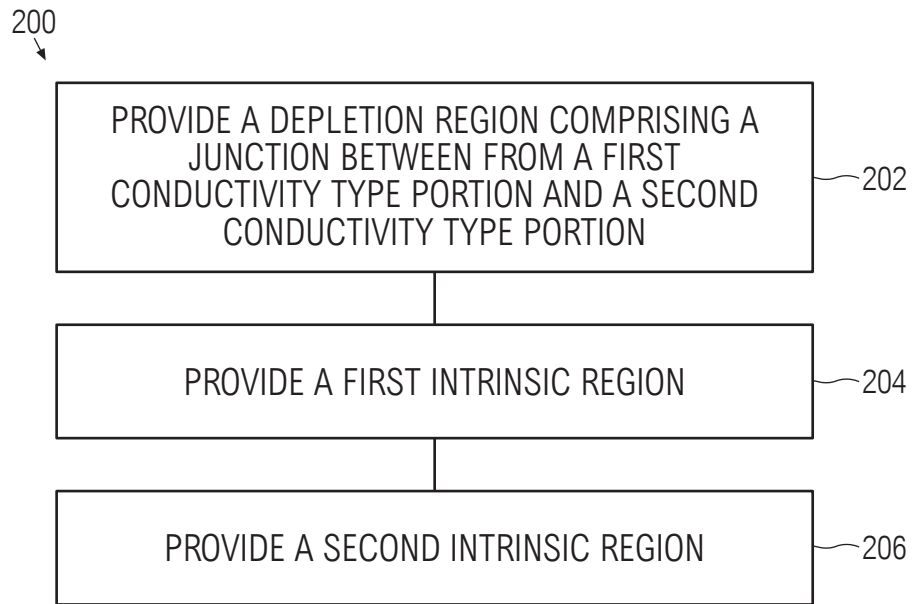
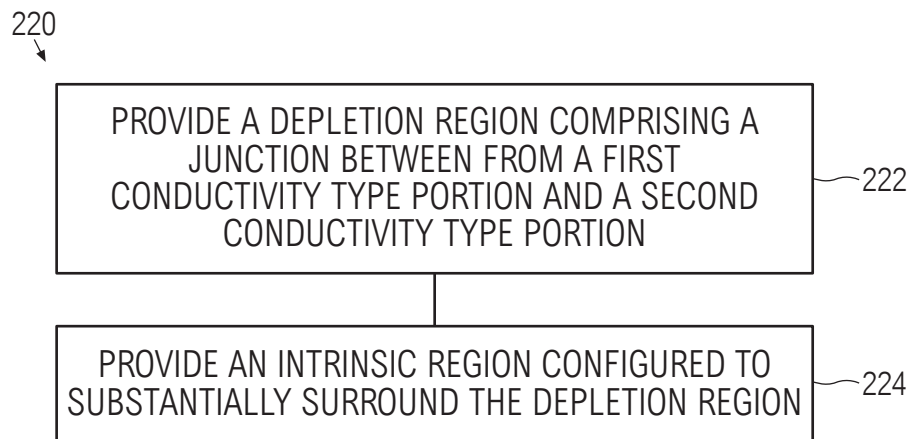


FIG. 1C

*FIG. 2A**FIG. 2B*

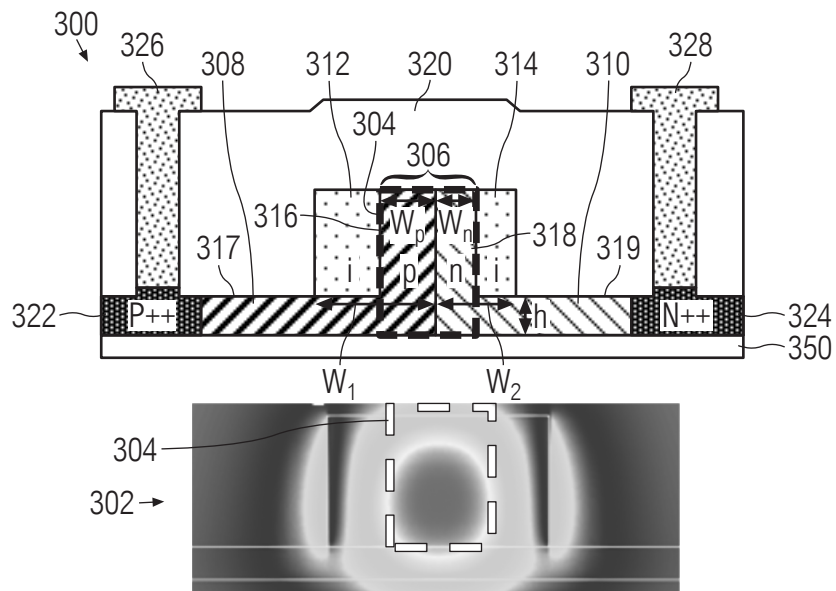


FIG. 3A

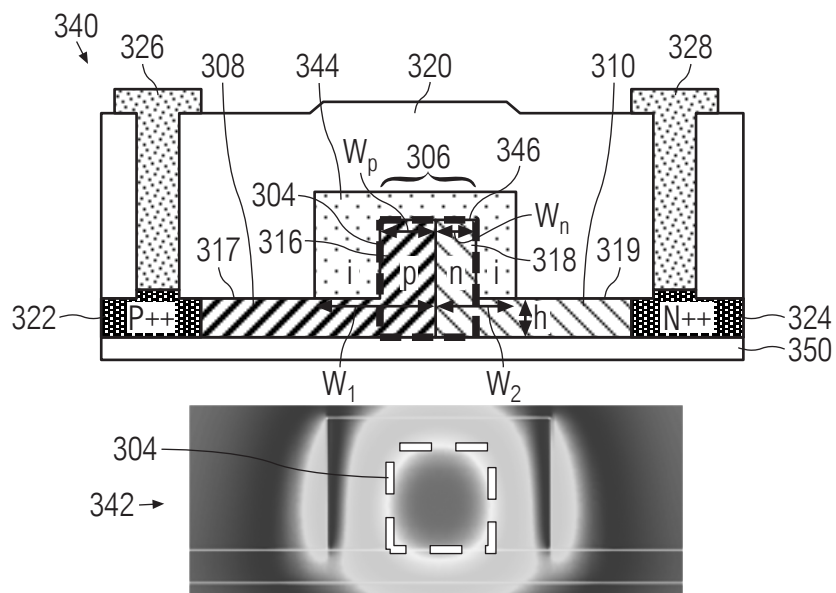


FIG. 3B

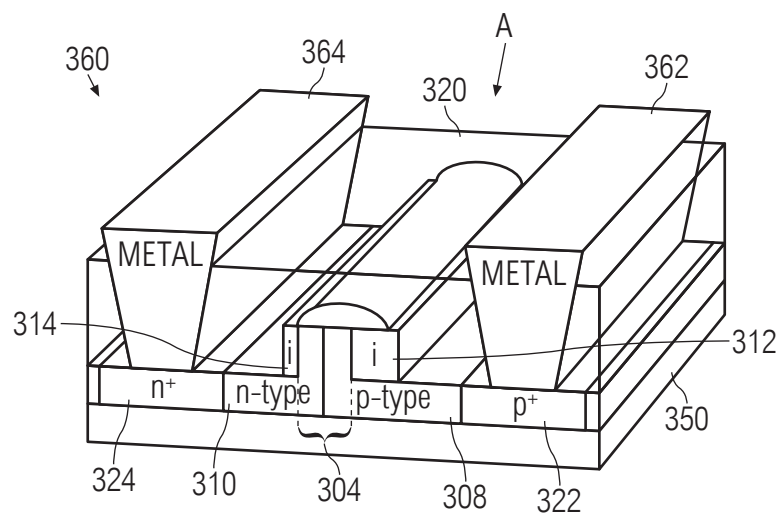


FIG. 3C

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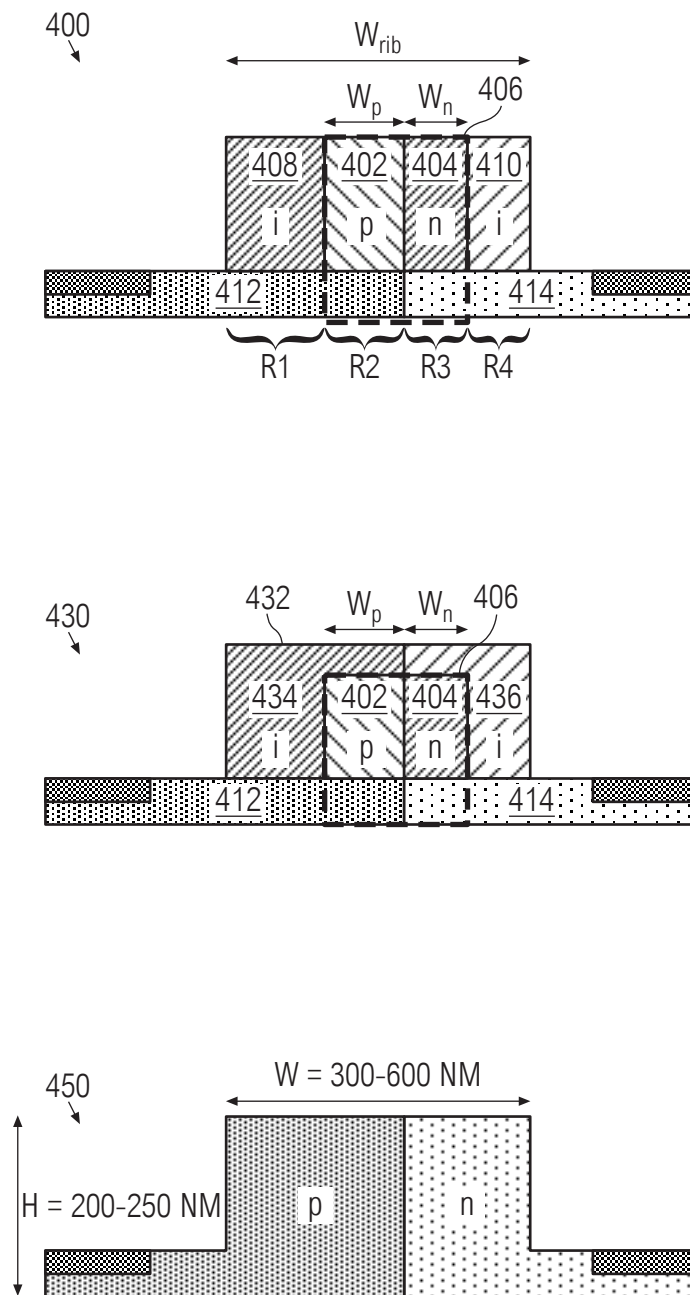
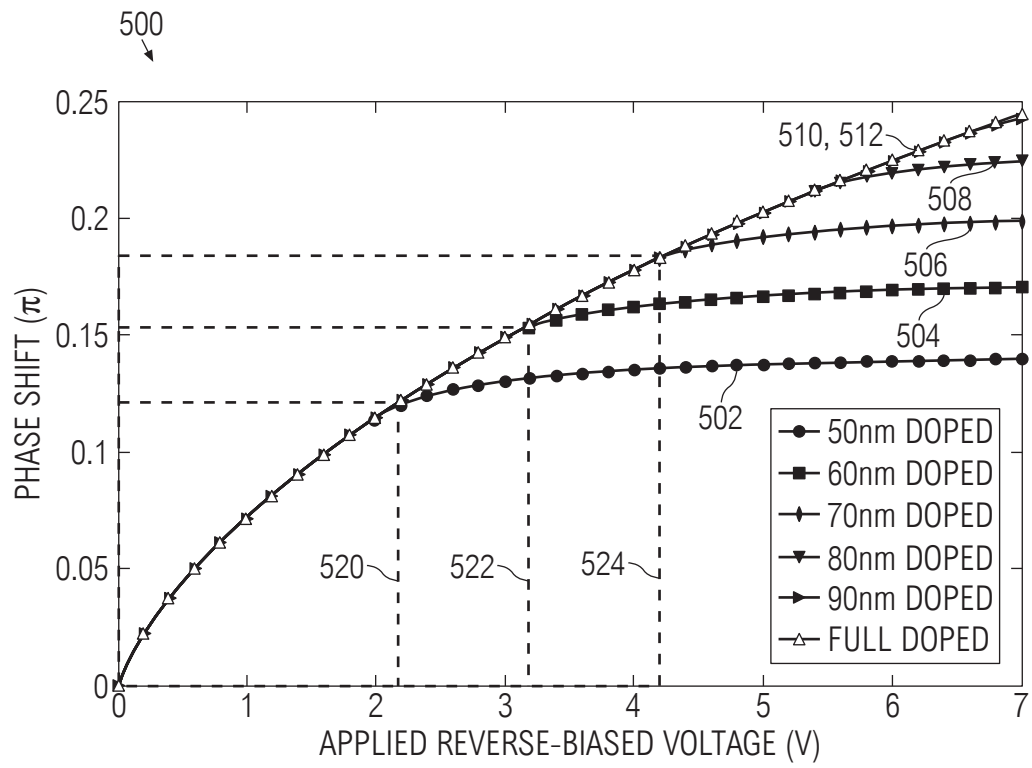
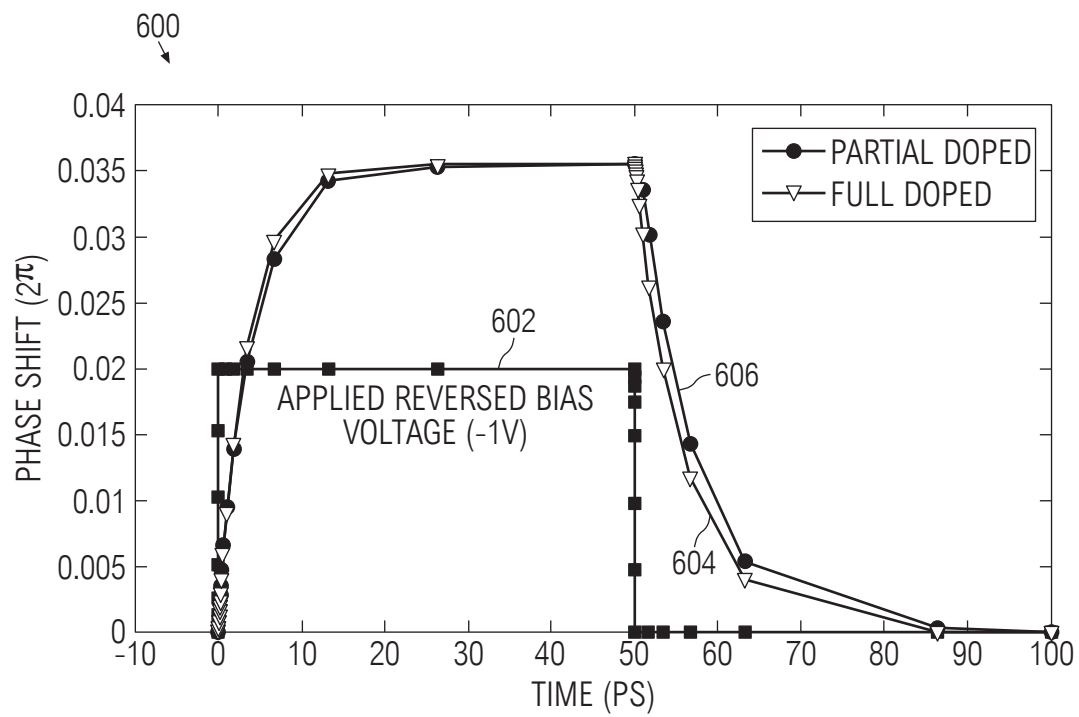


FIG. 4

**FIG. 5**

*FIG. 6*

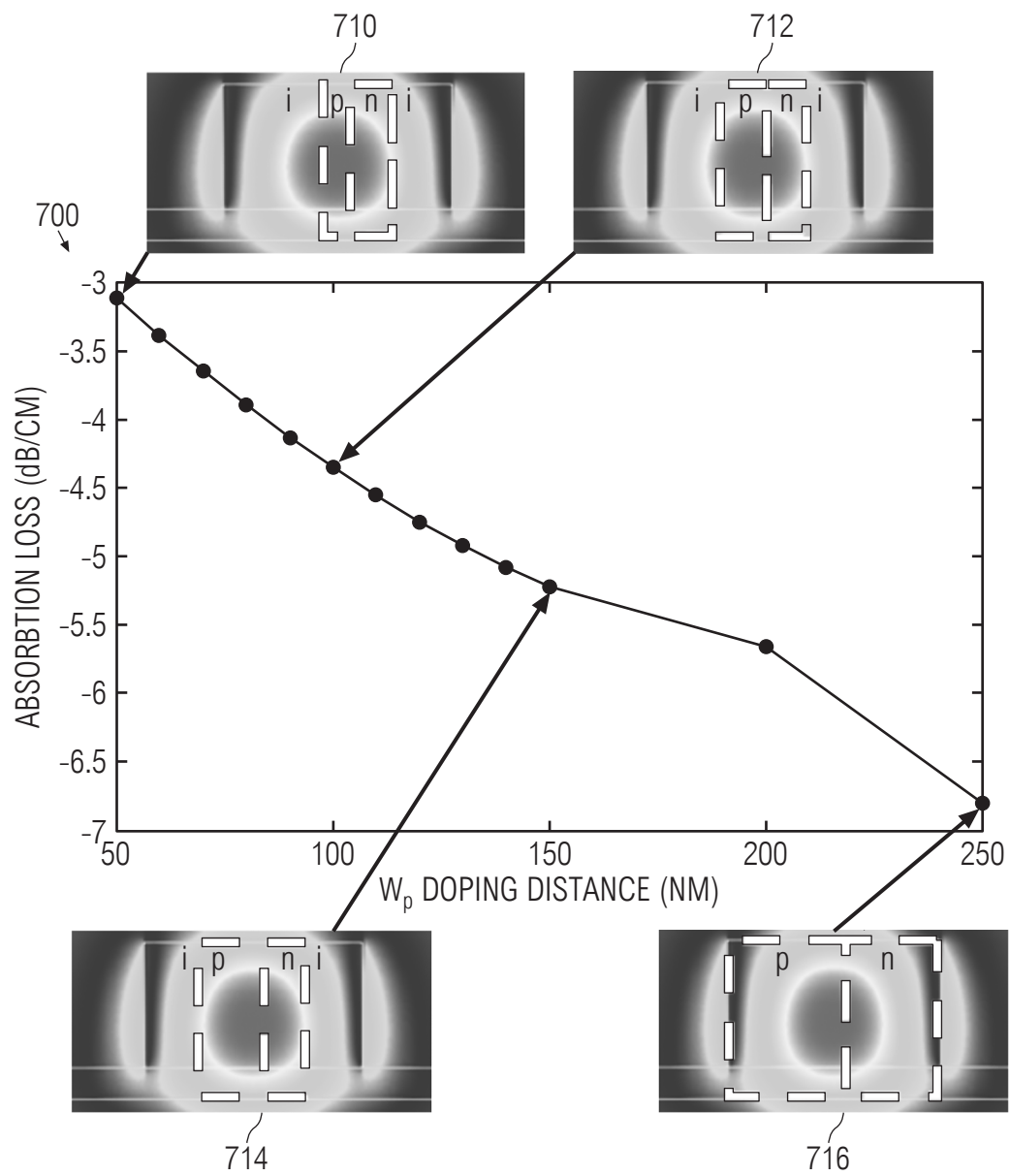


FIG. 7

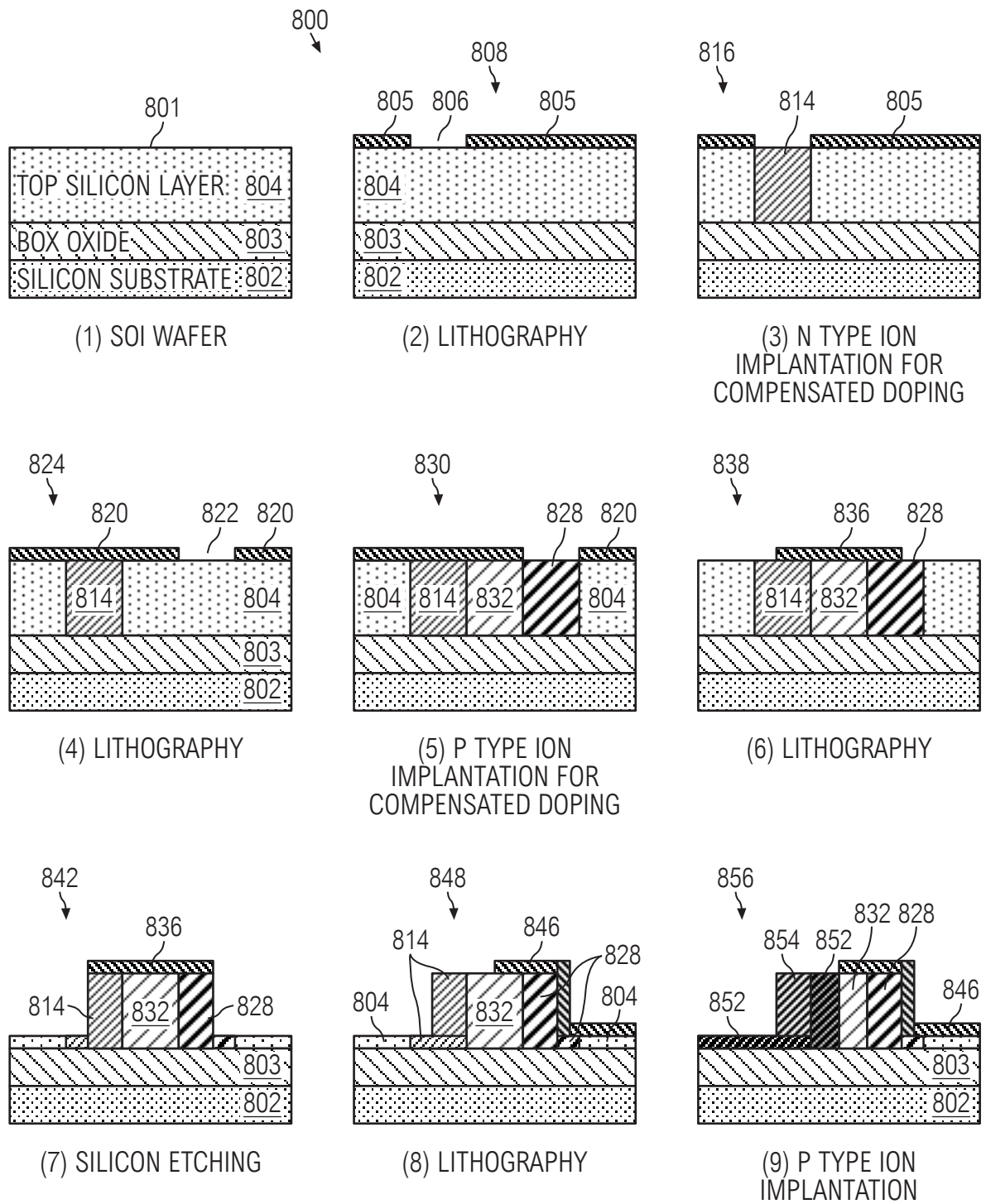
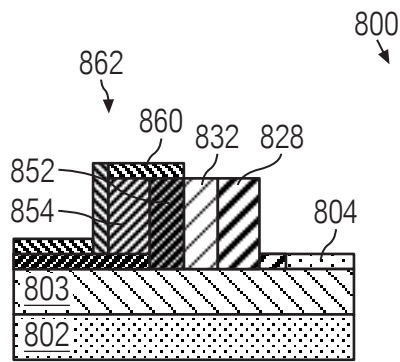
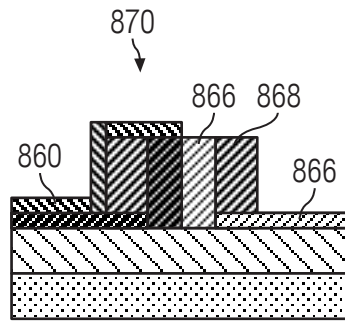


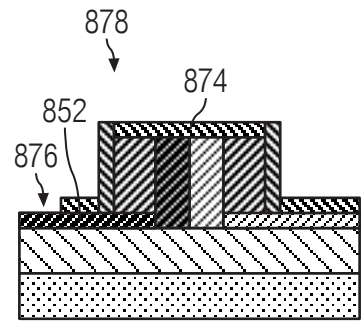
FIG. 8



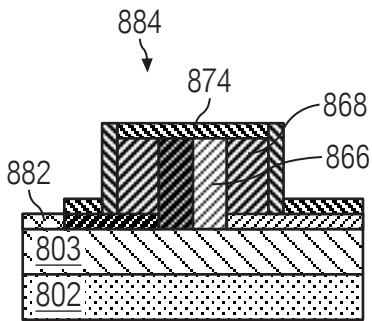
(10) LITHOGRAPHY



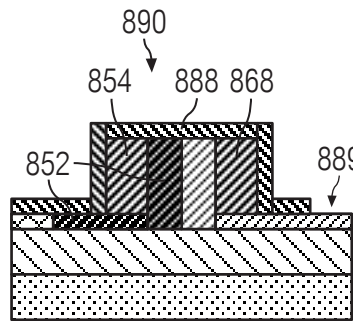
(11) N TYPE ION
IMPLANTATION



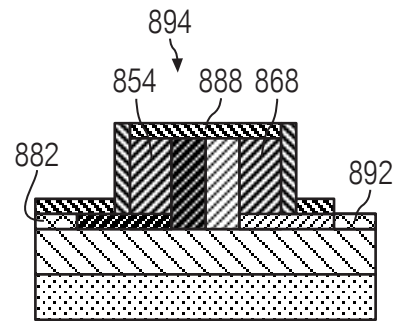
(12) LITHOGRAPHY



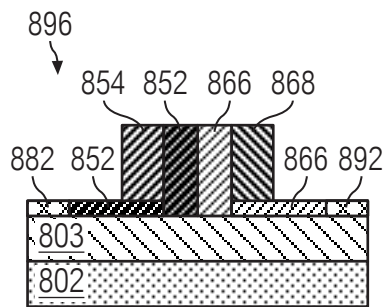
(13) P++ ION
IMPLANTATION



(14) LITHOGRAPHY



(15) N++ ION
IMPLANTATION



(16) REMOVE THE RESIST

FIG. 8

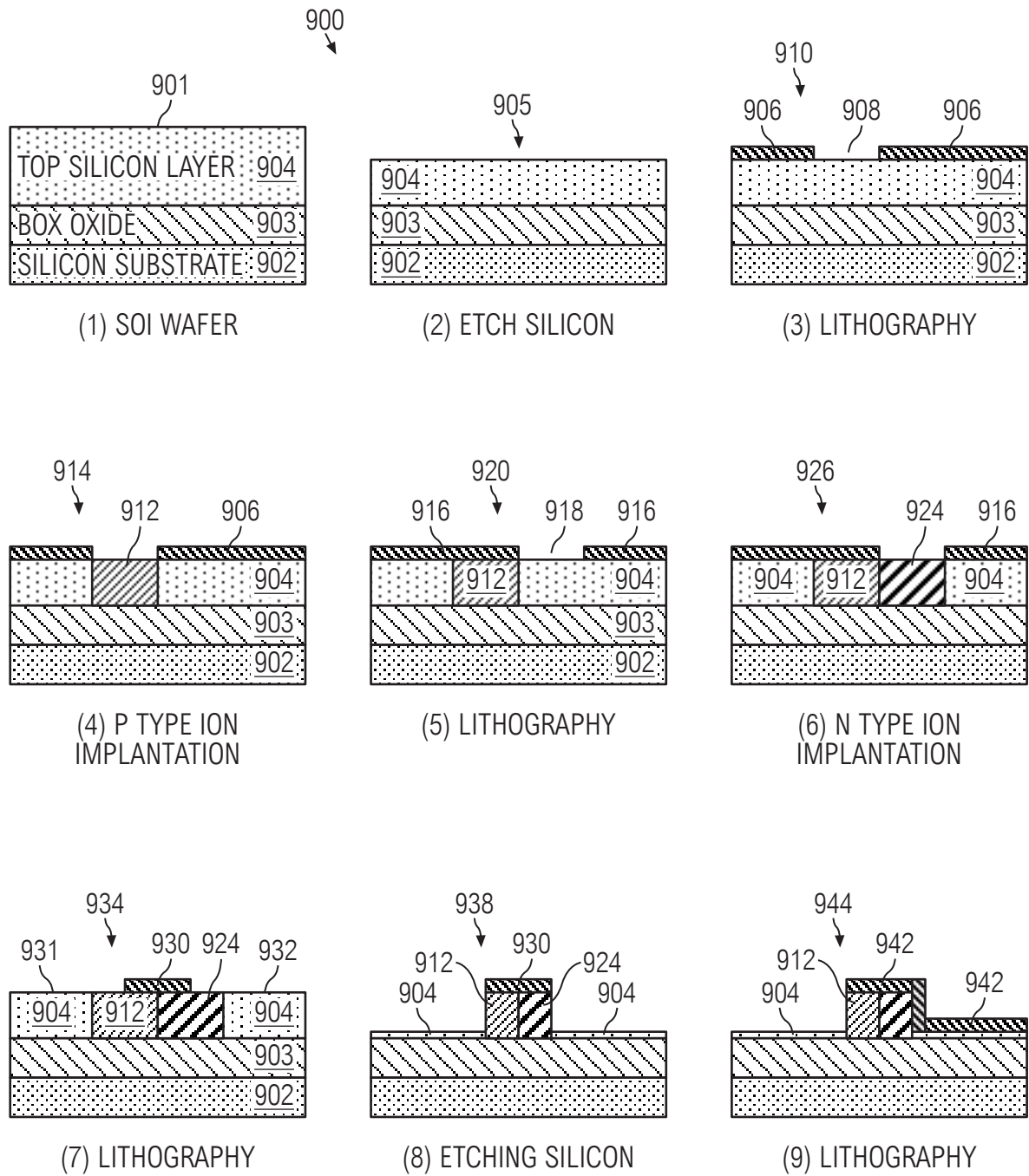


FIG. 9

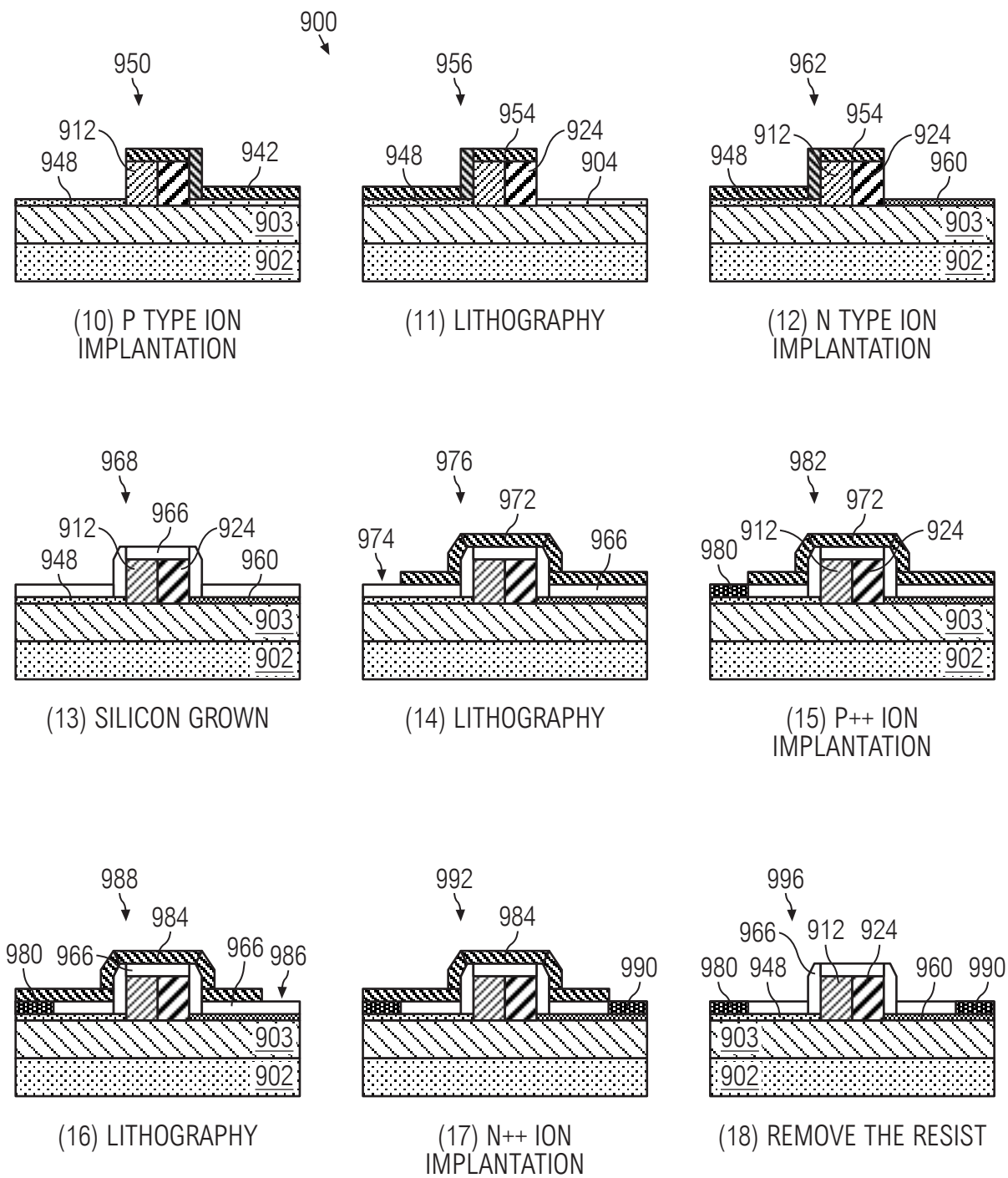
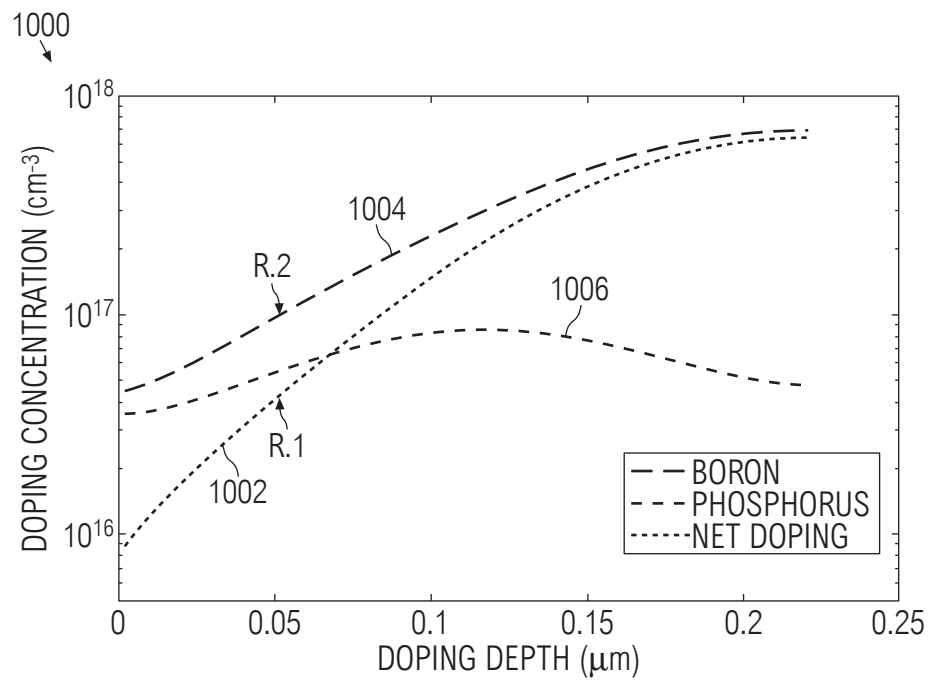
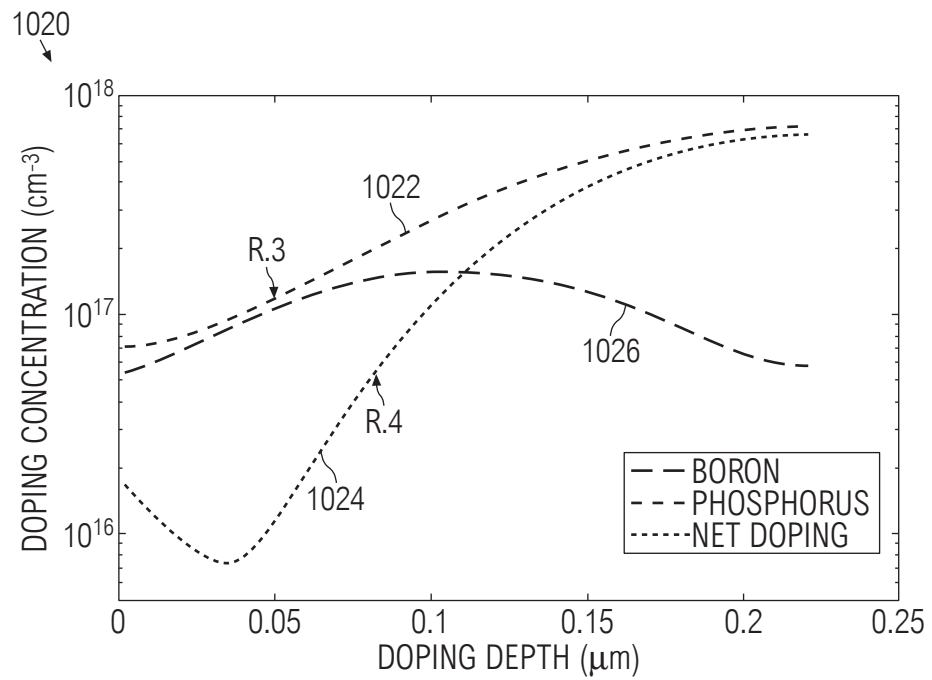
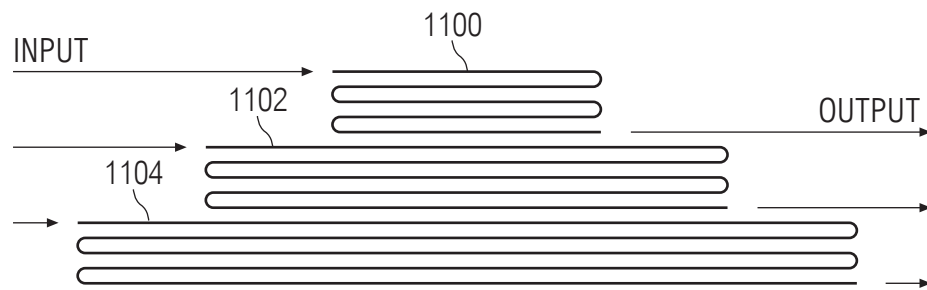
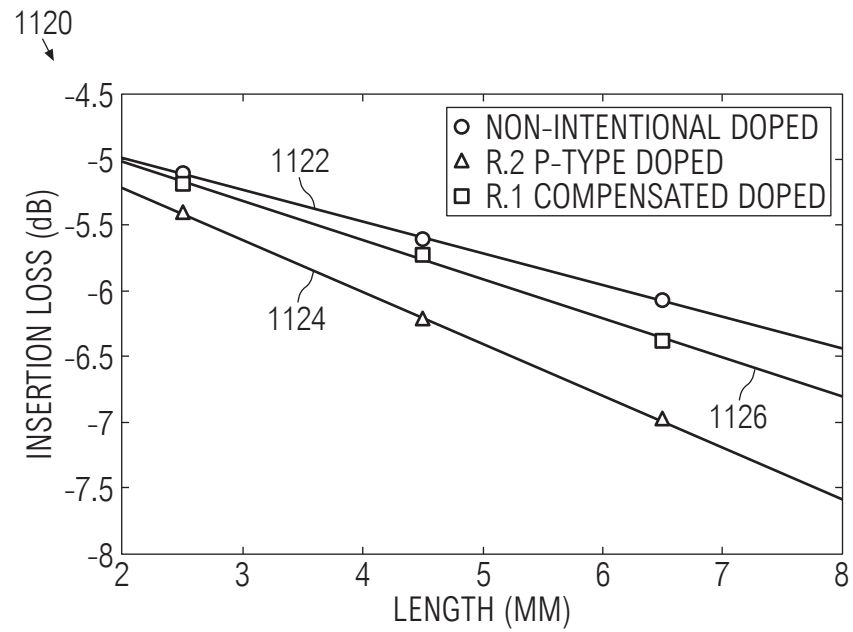
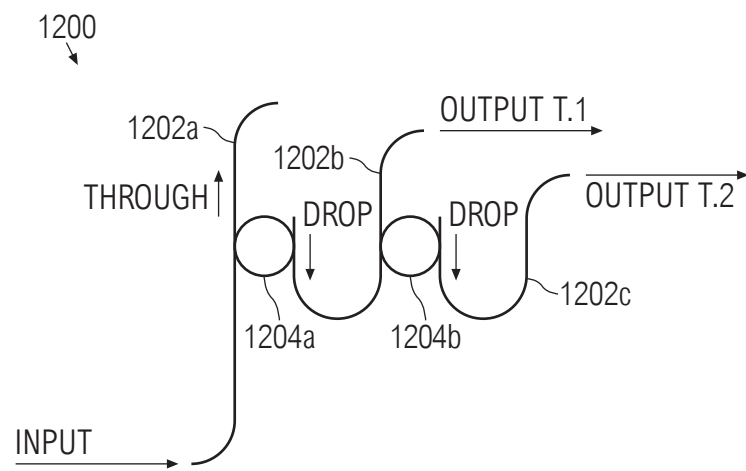
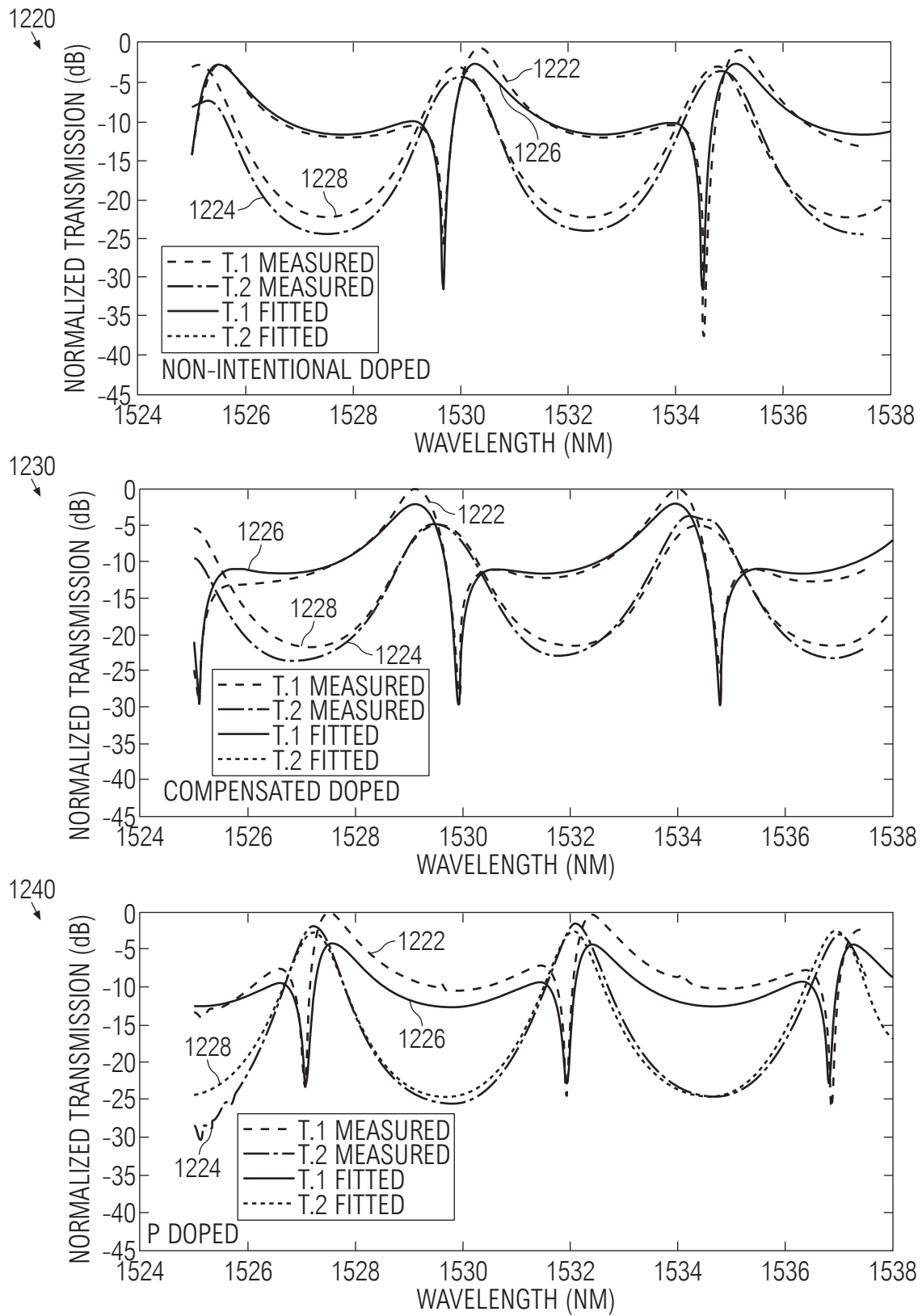


FIG. 9

**FIG. 10A****FIG. 10B**

*FIG. 11A**FIG. 11B*

**FIG. 12A**

**FIG. 12B**